

## Electronic Acknowledgement Receipt

<b>EFS ID:</b>	7945248
<b>Application Number:</b>	10530562
<b>International Application Number:</b>	
<b>Confirmation Number:</b>	8996
<b>Title of Invention:</b>	PRODUCTION METHOD FOR THIN-FILM CRYSTAL WAFER, SEMICONDUCTOR DEVICE USING IT AND PRODUCTION METHOD THEREFOR
<b>First Named Inventor/Applicant Name:</b>	Masahiko Hata
<b>Customer Number:</b>	23373
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<b>Filer Authorized By:</b>	Joseph J. Ruch
<b>Attorney Docket Number:</b>	Q87267
<b>Receipt Date:</b>	02-JUL-2010
<b>Filing Date:</b>	07-APR-2005
<b>Time Stamp:</b>	11:49:44
<b>Application Type:</b>	U.S. National Stage under 35 USC 371

### Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$ 180
RAM confirmation Number	10188
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### File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
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1		Q87267_IDS.pdf	193424	yes	4
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	Multipart Description/PDF files in .zip description				
	Document Description		Start	End	
	Transmittal Letter		1	2	
	Information Disclosure Statement (IDS) Filed (SB/08)		3	4	
Warnings:					
Information:					
2	NPL Documents	Q87267_Chinese_Office_Action.pdf	243490	no	6
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Warnings:					
Information:					
3	Foreign Reference	Q87267_JP57103351.pdf	136234	no	4
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Information:					
4	Foreign Reference	Q87267_JP60015970.pdf	263903	no	5
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Information:					
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Information:					
6	Fee Worksheet (PTO-875)	fee-info.pdf	30747	no	2
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Warnings:					
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Total Files Size (in bytes):			1111647		

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**New Applications Under 35 U.S.C. 111**

**If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.**

**National Stage of an International Application under 35 U.S.C. 371**

**If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.**

**New International Application Filed with the USPTO as a Receiving Office**

**If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.**